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NO. 1779 P. 1

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Docket No. 200819-1052

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yoshihisa NAGANO et al.

Serial No.10/829,476

Filed: April 22, 2004

For: *Semiconductor Device and Method of
Fabricating the Same*

)

) Group Art Unit:2826

) Examiner: Not Yet Assigned

)

) Date: December 15, 2004

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I hereby certify that this correspondence is being facsimile transmitted to the Patent and Trademark Office (Fax No. (703) 872-9306) on December 15, 2004.


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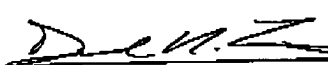
STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please advise, in writing, as to the current status of the above-identified application.

Respectfully submitted,


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